

## **Search Notes**



**Application/Control No.**

10/540,256

**Examiner**

Tae W. Kim

**Applicant(s)/Patent under  
Reexamination**

GOWER ET AL.

## **Art Unit**

2887

SEARCHED

**INTERFERENCE SEARCHED**

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)